

# A Cylindrical Multiconductor Stripline-Like Microstrip Transmission Line

DOREL HOMENTCOVSCHI

**Abstract**—An analytical expression for the Maxwell capacitance matrix of a class of cylindrical inhomogeneous, multiconductor transmission lines is provided. This class includes cylindrical structures symmetrical with respect to the circuit circle and having a symmetry axis. The effective dielectric constant of the line is found to be the arithmetical mean of the dielectric constants of the two media. Hence, this structure enjoys the main advantages of the planar stripline-like microstrip systems. It is also pointed out how to obtain elliptical stripline-like microstrip transmission lines.

## I. INTRODUCTION

**I**N HIS PAPER Garg [1] considered a transmission configuration which has the advantages of both stripline and microstrip line. This new transmission line consists in an inhomogeneous planar shielded structure having equal spacing (substrate thicknesses) between the plane of the circuit and the upper and lower shield planes. In [2] analytical formulas for determining the Maxwell capacitance matrix of multiconductor coupled stripline-like microstrip lines are given. The results obtained confirm that the dominant propagation modes have the same phase velocities independent of the strip widths and spacing and that the velocities are given by the phase velocity of the uncoupled line. This characteristic will result in a very good directivity for multiconductor coupled line directional couplers which use stripline-like microstrip.

Using flexible dielectric materials, it is possible to construct nonplanar transmission lines that can be wrapped around a cylindrical surface. This generates the cylindrical transmission lines which, in the quasi-TEM operating mode, have recently received much attention in the microwave literature. The first approach entails the solution of the Laplace equation in orthogonal curvilinear coordinates (cylindrical or elliptical); in this way Wang [3] analyzed homogeneous cylindrical striplines and microstrip lines, Reddy and Deshpande [4] the cylindrical stripline with multilayer dielectrics, and Joshi and Das [5] homogeneous elliptical striplines. In this method the solution is expressed as an infinite series and the constants are deter-

mined by truncating the series; hence the analysis is not rigorous and the solutions are approximate. The second approach [6]–[8] uses conformal mapping of the given structure into a planar one and, further on, uses known results for planar structures [9]. The method is rigorous but in this form it is not suitable for the analysis of cylindrical multiconductor transmission lines. Chan and Mittra [10] applied another approach, the spectral-domain technique [11], to study cylindrical multiconductor transmission lines. This method allows a rigorous numerical iterative procedure which uses the fast Fourier transform algorithm.

This paper presents an analysis leading, in principle, to an exact evaluation of parameters for an extensive class of cylindrical inhomogeneous strip transmission line configurations. The method is based on conformal mapping and on the evaluation of Maxwell's capacitance matrix for the system of aligned planar strips given in [2]. The domain must have a symmetry plane and at the same time must be symmetrical with respect to the circuit surface. In the case of the circular cylindrical structure, this requires that the radius of the circuit cylinder equal the geometrical mean of the radii of the two shield cylindrical surfaces. The assumption that the domain is symmetrical with respect to the circuit surface eliminates most of the complications arising from the inhomogeneity of the dielectric substrate media because the perpendicular component of the electric field at the circuit surface is zero. The effective dielectric constant of the system is simply the arithmetical mean of the dielectric constant values of the two substrate media. Hence, the structure presented here has the principal advantage of the symmetrical plane structure, namely that the mode velocities are independent of the strip widths and spacing; this is why the above structure can be thought of as a cylindrical stripline-like microstrip structure.

It is to be noticed that the above-mentioned symmetry of the structure with respect to a plane is necessary only for computation of the Maxwell capacitance matrix. The independence of the mode velocities of the strip dimensions and spacing also holds if the last symmetry condition is given up. By using certain conformal mappings the above results can be extended to such other nonplanar structures as elliptical stripline-like microstrip structures, which are discussed here as well.

Manuscript received March 14, 1988; revised August 19, 1988.

The author is with the Faculty of Electrotechnics, Polytechnic Institute of Bucharest, 313 Splaiul Independentei, Bucharest, Romania.

IEEE Log Number 8825375.

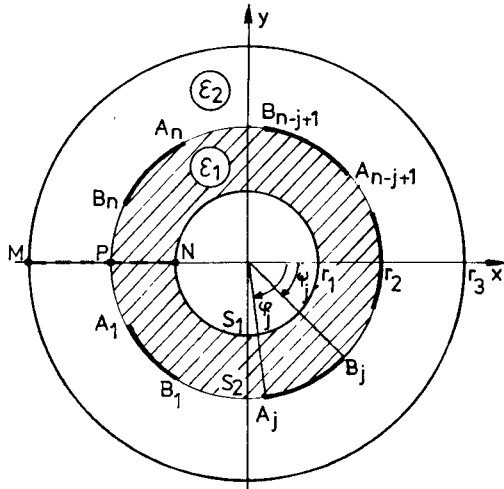


Fig. 1. Multiconductor cylindrical transmission line.

## II. BASIC CONFIGURATION AND CONFORMAL MAPPINGS

The cross section of the cylindrical multiconductor transmission line to be analyzed is shown in Fig. 1. It consists of three circles  $S_1, S_2, S_3$ ; the cylindrical surfaces  $S_1$  and  $S_3$  (of radii  $r_1$  and  $r_3$ , respectively) are grounded and the surface  $S_2$  (the circuit surface) separates the two different dielectric media whose relative dielectric constants are  $\epsilon_1$  and  $\epsilon_2$ . On the circuit surface are placed some zero-thickness conducting strips  $A_j B_j$  with arbitrary width and spacing but symmetrical with respect to the horizontal plane ( $Ox$  axis in Fig. 1). The position of the strips can be characterized by  $\varphi_j, \psi_j$  angles. It is assumed that  $r_2 = \sqrt{r_1 r_3}$ ; i.e., the radius of the circuit surface is the geometrical mean of the shield cylindrical surfaces.

To analyze this system, operating in the quasi-TEM mode, we use two conformal mappings. First, the logarithmic transform

$$z_1 = -i \ln \frac{z}{r_2} \quad (1)$$

maps the domain bounded by the circles  $S_1$  and  $S_2$  and the line cut into the symmetrical rectangle in the  $z_1 = x_1 + iy_1$  plane (Fig. 2).

The logarithm determination in (1) is the principal one and the abscissas of the points  $A_j, B_j$  will be  $\varphi_j, \psi_j$ , respectively. Further on, the domain in Fig. 2 is conformally mapped into the  $Z = X + iY$  plane with certain line cuts on the real axis (Fig. 3). This is obtained by using a Schwarz-Christoffel transform for representing the upper rectangle (dashed in Fig. 2) in the upper half-plane  $\text{Im}\{Z\} > 0$ ; by symmetry reasons the domain filled with dielectric medium of permittivity  $\epsilon_2$  is mapped into the half-plane  $Y < 0$ . Hence we have

$$Z = \text{sn}(z_1 \cdot K/\pi, k_1). \quad (2)$$

Here  $\text{sn}$  is the Jacobi function and  $K$  is the complete

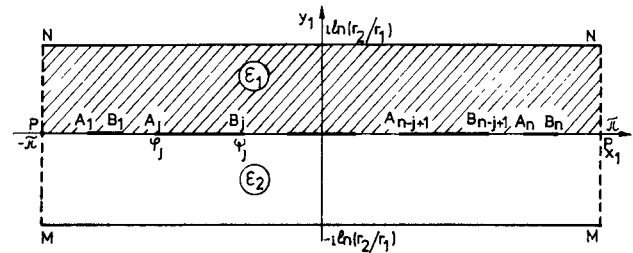


Fig. 2. The planar structure obtained by conformal mapping of the domain in Fig. 1.

elliptic integral of the first kind of modulus  $k_1$ . The modulus is the solution of the equation

$$\frac{K(k'_1)}{K(k_1)} = \frac{\ln(r_2/r_1)}{\pi}, \quad k'_1 = \sqrt{1 - k_1^2}. \quad (3)$$

The abscissas  $a_j, b_j$  of the points corresponding to the strip ends can be obtained as

$$a_j = \text{sn}(\varphi_j \cdot K/\pi, k_1) \quad b_j = \text{sn}(\psi_j \cdot K/\pi, k_1). \quad (4)$$

The symmetry of the domain in Fig. 1 with respect to the  $Ox$  axis implies the symmetry of the strips in Fig. 3 with respect to the vertical axis.

## III. DETERMINATION OF MAXWELL'S CAPACITANCE MATRIX

Let  $V_j, Q_j$  be, respectively, the potential and the charge on the strip  $A_j B_j$  and let  $b_0 \equiv b_{n+1}$  be the right end of the first (infinite) conducting strip and  $a_{n+1}$  the left end of the other infinite strip in Fig. 3. We use the expression relating the potentials and charges of a system of planar aligned strips given in [2] and [12]:

$$\sum_{k=1}^n \sum_{j=0}^{k-1} B(l, j) Q_k = (\epsilon_1 + \epsilon_2) \sum_{k=1}^n A(l, k) V_k \quad (l=1, \dots, n) \quad (5)$$

where

$$A(l, k) = (-1)^k \int_{a_k}^{b_k} \frac{t^{l-1}}{\sqrt{|P(t)|}} dt$$

$$B(l, k) = (-1)^{k+1} \int_{a_k}^{b_{k+1}} \frac{t^{l-1}}{\sqrt{|P(t)|}} dt$$

$$P(z) = \prod_{j=1}^{n+1} (z - a_j)(z - b_j). \quad (6)$$

In formula (5) we can take into account the symmetry of the strip. By also using the relation

$$\sum_{j=0}^n B(l, j) = 0$$

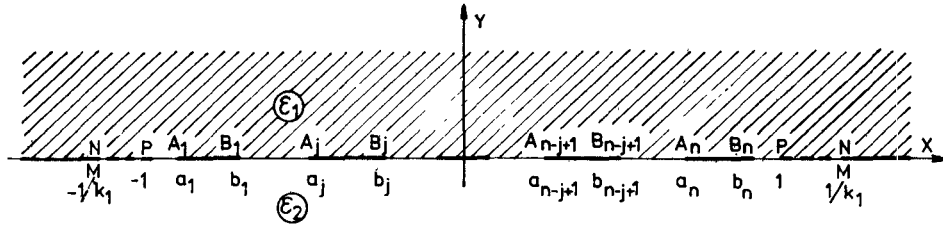


Fig. 3. The canonic domain obtained by conformal mappings of the domain in Fig. 1.

we get

$$\sum_{k=1}^p \sum_{j=0}^{k-1} B(l, j) [Q_k + (-1)^l Q_{2p-k+1}] = (\epsilon_1 + \epsilon_2) \sum_{k=1}^p A(l, k) [V_k + (-1)^l V_{2p-k+1}] \quad \text{for } n = 2p \text{ (even)} \quad (l=1, \dots, 2p) \quad (7)$$

$$\sum_{k=1}^p \sum_{j=0}^{k-1} B(l, j) [Q_k + (-1)^{l+1} Q_{2p-k}] + Q_p \sum_{j=0}^{p-1} B(l, j) = (\epsilon_1 + \epsilon_2) \left\{ \sum_{k=1}^{p-1} A(l, k) [V_k + (-1)^{l+1} V_{2p-k}] + V_p A(l, p) \right\} \quad \text{for } n = 2p-1 \text{ (odd)} \quad (l=1, \dots, 2p-1). \quad (8)$$

In relation (8) the coefficient of  $Q_p$  and  $A(l, p)$  vanishes for even values of the index  $l$ .

We now write

$$\begin{aligned} V_j &= V_j^e + V_j^o & Q_j &= Q_j^e + Q_j^o \\ V_{n-j+1} &= V_j^e - V_j^o & Q_{n-j+1} &= Q_j^e - Q_j^o \\ & \left( j=1, \dots, \left[ \frac{n}{2} \right] \right) \\ V_{\frac{n+1}{2}} &= V_{\frac{n+1}{2}}^e & Q_{\frac{n+1}{2}} &= Q_{\frac{n+1}{2}}^e \quad \text{for } n \text{ odd} \end{aligned} \quad (9)$$

and we split the problem into an "even" problem and an "odd" problem.

#### A. The Even Maxwell Capacitance Matrix

If the potentials of the strips are symmetrical with respect to the  $Ox$  axis in Fig. 1, we have  $V_j = V_{n-j+1} \equiv V_j^e$ ; the charges of the strips are symmetrical too,  $Q_j = Q_{n-j+1} \equiv Q_j^e$  and the line  $MN$  can be assumed to be a magnetic wall. In plane  $Z$  the lines  $MPN$  are field lines and, consequently, we have

$$b_0^e = b_{n+1}^e = -1/k_1 \quad a_{n+1}^e = 1/k_1$$

$$P^e(Z) = (Z^2 - k_1^{-2}) \prod_{j=1}^n (Z - a_j) \cdot (Z - b_j). \quad (10)$$

Relations (7) and (8) become

$$\sum_{k=1}^p \left( \sum_{j=0}^{k-1} B^e(2l', j) \right) Q_k^e = (\epsilon_1 + \epsilon_2) \sum_{k=1}^p A^e(2l', k) V_k^e \quad (l'=1, \dots, p) \quad \text{for } n = 2p \quad (11)$$

$$\sum_{k=1}^{p-1} \left( \sum_{j=0}^{k-1} B^e(2l'-1, j) \right) Q_k^e + \frac{1}{2} \left( \sum_{j=0}^{p-1} B^e(2l'-1, j) \right) Q_p^e = (\epsilon_1 + \epsilon_2) \left\{ \sum_{k=1}^{p-1} A^e(2l'-1, k) V_k^e + \frac{1}{2} A^e(2l'-1, p) V_p^e \right\} \quad (l'=1, \dots, p) \quad \text{for } n = 2p-1. \quad (12)$$

Relations (11) and (12) give

$$Q^e = C^e \cdot V^e \quad (13)$$

where the even Maxwell capacitance matrix is

$$C^e = (\epsilon_1 + \epsilon_2) [N^e]^{-1} \cdot M^e. \quad (14)$$

The matrices  $N^e, M^e$  have the entries

$$N^e(l', k) = \sum_{j=0}^{k-1} B^e(2l', j)$$

$$M^e(l', k) = A^e(2l', k) \quad (l', k=1, \dots, p) \quad (15)$$

for  $n = 2p$  and

$$N^e(l', k) = \sum_{j=0}^{k-1} B^e(2l'-1, j)$$

$$M^e(l', k) = A^e(2l'-1, k) \quad (k=1, \dots, p-1)$$

$$N^e(l', p) = 0.5 \sum_{j=0}^{p-1} B^e(2l'-1, j)$$

$$M^e(l', p) = 0.5 A^e(2l'-1, p) \quad (l'=1, \dots, p) \quad (16)$$

for  $n = 2p-1$ .

#### B. The Odd Maxwell Capacitance Matrix

In the case where the strip potentials in the physical plane are antisymmetrical with respect to the  $Ox$  axis we have  $V_j = -V_{n-j+1} \equiv V_j^o$  and the charges of the strips are

antisymmetrical too:  $Q_j = -Q_{n-j+1} \equiv Q_j^o$ . The line  $MN$  is now an electric wall at the zero potential and therefore the lines  $NPM$  in the  $Z$  plane are potential lines. We can write

$$b_0^o = b_{n+1}^o = -1 \quad a_{n+1}^o = 1$$

$$P^o(Z) = (Z^2 - 1) \prod_{j=1}^n (Z - a_j) \cdot (Z - b_j). \quad (17)$$

Relations (7) and (8) now give

$$\begin{aligned} \sum_{k=1}^p \left( \sum_{j=0}^{k-1} B^o(2l'-1, j) \right) Q_k^o \\ = (\epsilon_1 + \epsilon_2) \sum_{k=1}^p A^o(2l'-1, k) V_k^o \\ (l' = 1, \dots, p) \quad \text{for } n = 2p \end{aligned} \quad (18)$$

$$\begin{aligned} \sum_{k=1}^{p-1} \left( \sum_{j=0}^{k-1} B^o(2l', j) \right) Q_k^o = (\epsilon_1 + \epsilon_2) \sum_{k=1}^{p-1} A^o(2l', k) V_k^o \\ (l' = 1, \dots, p-1) \quad \text{for } n = 2p-1. \end{aligned} \quad (19)$$

We have

$$\mathbf{Q}^o = \mathbf{C}^o \mathbf{V}^o \quad (20)$$

where the odd Maxwell capacitance matrix is

$$\mathbf{C}^o = (\epsilon_1 + \epsilon_2) [\mathbf{N}^o]^{-1} \mathbf{M}^o. \quad (21)$$

The matrices  $\mathbf{N}^o, \mathbf{M}^o$  are given by relations (22), (23). For

Hence

$$\begin{aligned} C(j, k) = \begin{cases} 0.5[C^e(j, k) + C^o(j, k)] & \text{for } 1 \leq k \leq p \\ 0.5[C^e(j, 2p-k+1) - C^o(j, 2p-k+1)] & \text{for } p+1 \leq k \leq 2p \\ & (j = 1, \dots, p) \end{cases} \\ C(j, k) = \begin{cases} 0.5[C^e(2p-j+1, k) - C^o(2p-j+1, k)], & 1 \leq k \leq p \\ 0.5[C^e(2p-j+1, 2p-2k+1) + C^o(2p-j+1, 2p-k+1)] & \text{for } p+1 \leq k \leq 2p \\ & (j = p+1, \dots, 2p). \end{cases} \end{aligned} \quad (24)$$

Similarly in the case where  $n = 2p-1$  we obtain

$$\begin{aligned} C(j, k) = \begin{cases} 0.5[C^e(j, k) + C^o(j, k)], & 1 \leq k \leq p-1 \\ C^e(j, p), & k = p \\ 0.5[C^e(j, 2p-k) - C^o(j, 2p-k)], & p+1 \leq k \leq 2p-1 \\ & (j = 1, \dots, p-1) \end{cases} \\ C(p, k) = \begin{cases} 0.5C^e(p, k), & 1 \leq k \leq p-1 \\ C^e(p, p), & k = p \\ 0.5C^e(p, 2p-k), & p+1 \leq k \leq 2p-1 \end{cases} \\ C(j, k) = \begin{cases} 0.5[C^e(2p-j, k) - C^o(2p-j, k)], & 1 \leq k \leq p-1 \\ C^e(2p-j, p), & k = p \\ 0.5[C^e(2p-j, 2p-k) + C^o(2p-j, 2p-k)], & p+1 \leq k \leq 2p-1 \\ & (j = p+1, \dots, 2p-1) \end{cases} \end{aligned} \quad (25)$$

$n = 2p$  we have

$$N^o(l', k) = \sum_{j=0}^{k-1} B^o(2l'-1, j)$$

$$M^o(l', k) = A^o(2l'-1, j) \quad (l', k = 1, \dots, p) \quad (22)$$

while for  $n = 2p-1$ ,

$$\begin{aligned} N^o(l', k) = \sum_{j=0}^{k-1} B^o(2l', j) \quad M^o(l', k) = A^o(2l', k) \\ (l', k = 1, \dots, p-1). \end{aligned} \quad (23)$$

### C. The Complete Maxwell Capacitance Matrix

By using the even and odd Maxwell capacitance matrices given above we can now assemble the complete Maxwell matrix of the given structure. We have, for  $n = 2p$ ,

$$\begin{aligned} Q_j = Q_j^e + Q_j^o = \sum_{k=1}^p \{ C^e(j, k) V_k^e + C^o(j, k) V_k^o \} \\ = \sum_{k=1}^p 0.5[C^e(j, k) + C^o(j, k)] V_k \\ + \sum_{k=p+1}^{2p} 0.5[C^e(j, 2p-k+1) \\ - C^o(j, 2p-k+1)] V_k \quad \text{for } (j = 1, \dots, p). \end{aligned}$$

We shall now emphasize certain properties resulting from the above relations. Expressions (24) and (25) provide the Maxwell capacitance matrix of the given structure in terms of certain hyperelliptic integrals given by relations (6). The geometry of the physical domain enters these formulas only by the modulus  $k_1$  and the images in the  $Z$  plane of the end of the strips; these can be computed by means of relations (3) and (4). The effective determination of the Maxwell capacitance matrix involves some numerical quadrature and some algebra.

Let us now consider the case of the homogeneous dielectric medium ( $\epsilon_1 = \epsilon_2 = \epsilon_0$ ). Relations (13) and (21) give

$$C^e = \frac{\epsilon_1 + \epsilon_2}{2\epsilon_0} C_{\text{hom}}^e \quad C^o = \frac{\epsilon_1 + \epsilon_2}{2\epsilon_0} C_{\text{hom}}^o$$

where the matrices  $C_{\text{hom}}^e$ ,  $C_{\text{hom}}^o$  correspond to the homogeneous case. Relations (24) and (25) give

$$C = \frac{\epsilon_1 + \epsilon_2}{2\epsilon_0} C_{\text{hom}}. \quad (26)$$

Therefore, the Maxwell capacitance matrix of the multiconductor system in a stratified dielectric in Fig. 1 can be obtained by relation (26) if we know the matrix of the same multiconductor system in free space. Hence, the effective relative dielectric constant of the structure under consideration is

$$\epsilon_{\text{eff}} = \frac{\epsilon_1 + \epsilon_2}{2\epsilon_0}. \quad (27)$$

This quantity is independent of the strip width and spacing; consequently, this is valid for mode velocities too. Hence the structure shown in Fig. 1 presents the same advantages as stripline-like microstrip structures. It is natural to refer to them as cylindrical stripline-like microstrip structures.

#### IV. AN ELLIPTICAL MULTICONDUCTOR STRIPLINE-LIKE MICROSTRIP TRANSMISSION LINE

By using conformal mappings the above results can be extended to other geometries of the stripline. Let us assume, for example,

$$z = \frac{c}{2} \left( z + \frac{1}{z} \right) \quad (28)$$

where  $z = \zeta + i\eta$  is another complex variable. For  $z = re^{i\varphi}$ ,  $0 \leq \varphi < 2\pi$ , we obtain

$$\begin{aligned} \zeta &= \frac{c}{2} \left( r + \frac{1}{r} \right) \cos \varphi \\ \eta &= \frac{c}{2} \left( r - \frac{1}{r} \right) \sin \varphi, \quad 0 \leq \varphi < 2\pi. \end{aligned} \quad (29)$$

These relations give a parametric representation of an ellipse in the  $z$  plane of eccentricity  $c$  and semiaxes

$$a = \frac{c}{2} \left( r + \frac{1}{r} \right) \quad b = \frac{c}{2} \left( r - \frac{1}{r} \right). \quad (30)$$

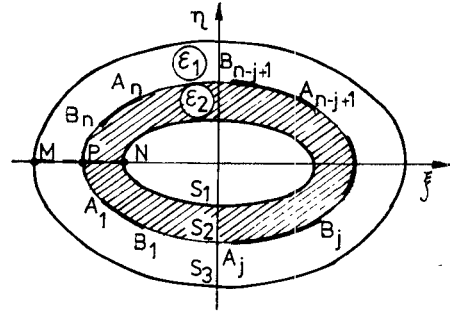


Fig. 4. The multiconductor elliptical transmission line.

The image of the domain plotted in the  $x$  plane by the mapping (28) is shown in Fig. 4. The semiaxes of the confocal ellipses  $S_1, S_2, S_3$  are given by relation (30) where  $r = r_1, r_2, r_3$ , respectively. The positions of the strips on the circuit ellipse are given by relations (29).

Since  $r = (a + b)/c$ ,  $c = \sqrt{a^2 - b^2}$ , the condition  $r_2^2 = r_1 r_3$  implies that

$$\frac{a_2 + b_2}{a_3 + b_3} = \frac{a_1 + b_1}{a_2 + b_2}. \quad (31)$$

Conversely, if we have a transmission line whose cross section contains the three confocal ellipses  $S_1, S_2, S_3$ , of semimajor axes  $a_1, a_2, a_3$  and semiminor axes  $b_1, b_2, b_3$  as in relation (31) and symmetrical with respect to the major axes, by using the conformal mapping

$$z = \frac{1}{c} (z + \sqrt{z^2 - c^2}) \quad (32)$$

we obtain the domain shown in Fig. 1. In the case where the striplines are symmetrical with respect to the minor axes we have to make an additional rotation of  $\pi/2$  to map the given domain into the domain considered in Fig. 1. The Maxwell capacitance matrix can be obtained by the formulas given above. Likewise, the mode velocities are independent of the strip sizes and positions on the circuit surface; therefore, this is an elliptical stripline-like microstrip transmission line.

#### V. APPLICATIONS

We shall now apply the obtained formulas to two simple structures with one or two coupled striplines. In these cases the given formulas provide analytical relations for the capacitances in terms of elliptic functions.

##### A. Single-Stripline Case

Since we have  $n = 2p - 1$ ,  $p = 1$ , we use the relations (14) and (16):

$$\begin{aligned} N^e(1, 1) &= 0.5B^e(1, 0) = -\frac{1}{2} \int_{-b_0}^{a_1} \frac{dt}{\sqrt{(k_1^{-2} - t^2)(t^2 - a_1^2)}} \\ &= -0.5k_1 K(\sqrt{1 - a^2 k_1^2}) \end{aligned}$$

$$\begin{aligned} M^e(1, 1) &= 0.5A^e(1, 1) = -\frac{1}{2} \int_{a_1}^{b_1} \frac{dt}{\sqrt{(k_1^{-2} - t^2)(t^2 - a_1^2)}} \\ &= -k_1 K(a \cdot k_1). \end{aligned}$$

Hence

$$\frac{C^e}{\epsilon_1 + \epsilon_2} = \frac{2K(ak_1)}{K(\sqrt{1-a^2k_1^2})}. \quad (33)$$

In this case we have

$$\varphi_1 = -\varphi \quad \psi_1 = \varphi \quad b_1 = -a_1 \equiv a = \text{sn}(\varphi K/\pi, k_1).$$

If  $\ln(r_2/r_1) \ll \pi$  and  $\varphi \ll \pi$  we can approximate the domain in the  $z_1$  plane by an infinite strip and, correspondingly, the conformal mapping function becomes

$$Z = \tanh \frac{\pi z_1}{2 \ln(r_2/r_1)}. \quad (34)$$

In this case we have

$$k_1 = 1 \quad a = \tanh \frac{\pi \varphi}{2 \ln(r_2/r_1)} \\ \sqrt{1-a^2k_1^2} = \text{sech} \left( \frac{\pi \varphi}{2 \ln(r_2/r_1)} \right) \equiv s. \quad (35)$$

The characteristic impedance of the line is

$$Z_0 = \frac{Z_{0v}}{\sqrt{\epsilon_{\text{eff}}}} \cdot \frac{K(s)}{K(s')} \quad (36)$$

where  $Z_{0v} = \sqrt{\mu_0/\epsilon_0} = 376.7 \Omega$  is the characteristic impedance of free space. In the case where  $\epsilon_1 = \epsilon_2$ , relation (36) coincides with that given in [8].

### B. Two Equal Striplines

In this case  $n = 2p$ ,  $p = 1$ . Let  $\psi_2 = -\varphi_1 = \psi$ ,  $\varphi_2 = -\psi_1 = \varphi$  be the angles characterizing the ends of the two strips. We have

$$b_2 = -a_1 = b \quad a_2 = -b_1 = a \\ a = \text{sn}(\varphi K/\pi, k_1) \\ b = \text{sn}(\psi K/\pi, k_1). \quad (37)$$

Relations (14) and (15) give

$$\frac{C^e}{\epsilon_1 + \epsilon_2} = \frac{M^e(1,1)}{N^e(1,1)} = \frac{K(s_e)}{K(s'_e)}, \quad s_e = k_1 \frac{\sqrt{b^2 - a^2}}{\sqrt{1 - k_1^2 a^2}}. \quad (38)$$

Similarly, the odd capacity results by using formulas (21) and (22):

$$\frac{C^o}{\epsilon_1 + \epsilon_2} = \frac{M^o(1,1)}{N^o(1,1)} = \frac{K(s_o)}{K(s'_o)}, \quad s_o = \frac{\sqrt{b^2 - a^2}}{b\sqrt{1 - a^2}}. \quad (39)$$

Relations (24) give the complete Maxwell capacitance ma-

trix in the form

$$C(1,1) = C(2,2) = \frac{1}{2}(C^e + C^o) = \epsilon_{\text{eff}} \left\{ \frac{K(s_e)}{K(s'_e)} + \frac{K(s_o)}{K(s'_o)} \right\} \\ C(1,2) = C(2,1) = \frac{1}{2}(C^e - C^o) = \epsilon_{\text{eff}} \left\{ \frac{K(s_e)}{K(s'_e)} - \frac{K(s_o)}{K(s'_o)} \right\}. \quad (40)$$

## VI. CONCLUSIONS

A class of cylindrical multiconductor transmission lines has been analyzed by using the conformal mapping and the relations between the potentials and the charges of the system of aligned planar strips given in [2]. This class includes cylindrical lines having the radius of the circuit circle as the geometrical mean of the two ground circle radii. In addition, the system exhibits a symmetry axis.

The paper provides an analytical expression of the Maxwell capacitance matrix in terms of hyperelliptic integrals. The capacitance matrix of the multistrip system in a stratified dielectric is expressed by relation (26) in terms of the Maxwell capacitance matrix of the same system placed in free space. Since the effective dielectric constant of the structure is simply the arithmetical mean of the dielectric constants of the two substrate media, the mode velocity is constant and therefore the considered cylindrical structure enjoys the properties of planar stripline-like microstrip structures. It is also pointed out how these results can be extended to elliptical multiconductor transmission lines.

## REFERENCES

- [1] R. Garg, "Stripline-like microstrip configuration," *Microwave J.*, vol. 22, pp. 103-104, Apr. 1979.
- [2] D. Homentcovschi, A. Manolescu, A. M. Manolescu, and L. Kreinder, "An analytical solution for the coupled stripline-like microstrip lines problem," *IEEE Trans. Microwave Theory Tech.*, vol. 36, pp. 1002-1007, June 1988.
- [3] Y. C. Wang, "Cylindrical and cylindrically warped strip and microstrip lines," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-26, pp. 20-23, Jan. 1978.
- [4] C. J. Reddy and M. D. Deshpande, "Analysis of cylindrical stripline with multilayer dielectrics," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-34, pp. 701-706, June 1986.
- [5] K. K. Joshi and B. N. Das, "Analysis of elliptic and cylindrical striplines using Laplace's equation," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-28, pp. 381-386, Apr. 1980.
- [6] K. K. Joshi, J. S. Rao, and B. N. Das, "Characteristic independence of nonplanar striplines," *Proc. Inst. Elec. Eng.*, pt. H, vol. 127, pp. 287-290, Aug. 1980.
- [7] B. N. Das, A. Chakrabarty, and K. K. Joshi, "Characteristic impedance of elliptic cylindrical strip and microstrip lines filled with layered substrate," *Proc. Inst. Elec. Eng.*, pt. H, vol. 130, pp. 245-250, June 1983.
- [8] L. R. Zeng and Y. X. Wang, "Accurate solutions of elliptical and cylindrical striplines and microstrip lines," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-34, pp. 259-265, Feb. 1986.
- [9] J. S. Rao and B. N. Das, "Analysis of asymmetric stripline by conformal mapping," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-27, pp. 299-303, Apr. 1979.
- [10] C. H. Chan and R. Mittra, "Analysis of a class of cylindrical multiconductor transmission lines using an iterative approach," *IEEE Trans. Microwave Theory Tech.*, vol. MTT-35, pp. 415-424, Apr. 1987.

- [11] Y. Rahmat-Samii, T. Itoh, and R. Mittra, "A spectral domain technique for solving microstrip line problems," *Arch. Elek. Übertragung*, Band 27, pp. 69-71, 1973.
- [12] D. Homentcovschi, A. Manolescu, A. M. Manolescu, and C. Burileanu, "A general approach to analysis of distributed resistive structures," *IEEE Trans. Electron Devices*, vol. ED-25, pp. 787-794, July 1978.



**Dorel Homentcovschi** was born in Dondosani, Romania, on October 22, 1942. He received the M.Sc. degree in 1965 and the Ph.D. degree in 1970, both from the Faculty of Mathematics and Mechanics, University of Bucharest, Romania.



In 1970 he joined the Polytechnic Institute of Bucharest, where he is presently an Associate Professor of Applied Mathematics in the Department of Electrical Engineering and the Department of Electronics. He is coauthor of the book *Classical and Modern Mathematics* (vols. III and IV) and author of the book *Complex Variable Functions and Applications in Science and Technique*. He has written many scientific papers and reports. His research interests are in the areas of boundary-value problems, numerical methods, fluid mechanics, magnetofluid dynamics, electrotechnics, and microelectronics.

Dr. Homentcovschi was awarded the Gheorghe Lazar prize for a paper on aerodynamics and the Traian Vuia prize for a work concerning multiterminal distributed resistive structures, both from the Romanian Academy, in 1974 and 1978, respectively.

---